

Notice of References Cited

 Application/Control No.
 10/533,396

 Applicant(s)/Patent Under
 Reexamination
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U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-7,284,569	10-2007	Takemaru, Ryuhei	137/545
	B	US-			
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	D	US-			
	E	US-			
	F	US-			
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

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